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SERIAL NUMBER	FILING DATE	FIRST NAMED APPLICANT		ATTORNEY DOCKET NO.
08/988,686	12/11/9	7 KONECNI	Α	TI-22166

MM21/0128

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EXAMINER

EATON, K

ART UNIT PAPER NUMBER

2814

DATE MAILED: 01/28/99

Please find below a communication from the EXAMINER in charge of this application.

Commissioner of Patents

Office Action Summary

Application No. 08/988,686 Applicant(s)

Examiner **Kurt Eaton** **Group Art Unit** 2814

Konecni et al.

This action is FINAL .	
Since this application is in condition for allowance except for form in accordance with the practice under Ex parte Quayle, 1935 C.D.). 11; 453 O.G. 213.
A shortened statutory period for response to this action is set to expendence in the mailing date of this communication. Failure to respond to become abandoned. (35 U.S.C. § 133). Extensions (37 CFR 1.136(a).	spong within the belief for response will cause the
Disposition of Claims	total and the state and total and
	is/are pending in the application.
Of the above, claim(s)	
☐ Claim(s)	
☐ Claim(s)	is/are rejected.
Claim(s)	is/are objected to.
	are subject to restriction or election requirement.
Application Papers See the attached Notice of Draftsperson's Patent Drawing Re The drawing(s) filed on is/are objected to The proposed drawing correction, filed on is/are objected to The specification is objected to by the Examiner. The oath or declaration is objected to by the Examiner. Priority under 35 U.S.C. § 119 Acknowledgement is made of a claim for foreign priority under all Some* None of the CERTIFIED copies of the received. Teceived in Application No. (Series Code/Serial Number received in this national stage application from the Interest Acknowledgement is made of a claim for domestic priority under Acknowledgement is made of a claim for domestic priority under the priority under the stage application from the Interest acknowledgement is made of a claim for domestic priority under the stage application from the Interest acknowledgement is made of a claim for domestic priority under the stage application from the Interest acknowledgement is made of a claim for domestic priority under the stage acknowledgement is made of a claim for domestic priority under the stage acknowledgement is made of a claim for domestic priority under the stage acknowledgement is made of a claim for domestic priority under the stage acknowledgement is made of a claim for domestic priority under the stage acknowledgement is made of a claim for domestic priority under the stage acknowledgement is made of a claim for domestic priority under the stage acknowledgement is made of a claim for domestic priority under the stage acknowledgement is made of a claim for domestic priority under the stage acknowledgement is made of a claim for domestic priority under the stage acknowledgement is made of a claim for domestic priority under the stage acknowledgement is made of a claim for domestic priority under the stage acknowledgement is made of a claim for domestic priority under the stage acknowledgement is made of a claim for domestic priority under the stage acknowledgement is acknowledgement is acknowledgement is ac	o by the Examinerisapproveddisapproved. er 35 U.S.C. § 119(a)-(d). e priority documents have been er ernational Bureau (PCT Rule 17.2(a)).
Attachment(s) ☐ Notice of References Cited, PTO-892 ☒ Information Disclosure Statement(s), PTO-1449, Paper No(s) ☐ Interview Summary, PTO-413 ☒ Notice of Draftsperson's Patent Drawing Review, PTO-948 ☐ Notice of Informal Patent Application, PTO-152	3

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Art Unit: 2814

DETAILED ACTION

Election/Restriction

- 1. Restriction to one of the following inventions is required under 35 U.S.C. 121:
 - I. Claims 1-15, drawn to a method of coupling a conductive material to a contact region of a semiconductor device, classified in class 438, subclass 597.
 - II. Claims 16-20, drawn to an integrated cluster tool for selectively coupling a conductive material to a contact region of a semiconductor device, classified in class 118, subclass 723 R.
- 2. The inventions are distinct, each from the other because of the following reasons: Inventions I and II are related as process and apparatus for its practice. The inventions are distinct if it can be shown that either: (1) the process as claimed can be practiced by another materially different apparatus or by hand, or (2) the apparatus as claimed can be used to practice another and materially different process. (MPEP § 806.05(e)). In this case the integrated cluster tool for selectively coupling a conductive material to a contact region of a semiconductor device could be used to coat any portion of any surface with any conductive material.
- 3. Because these inventions are distinct for the reasons given above and have acquired a separate status in the art as shown by their different classification, restriction for examination purposes as indicated is proper.

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Applicant is advised that the reply to this requirement to be complete must include an election of the invention to be examined even though the requirement be traversed (37 CFR 1.143).

Conclusion

4. Paper related to this application may be submitted directly to Art Unit 2814 by facsimile transmission. Papers should be faxed to Art Unit 2814 via the Art Unit 2814 Fax Center located in the Crystal Plaza 4, room 4C23. The faxing of such papers must conform with the notice published in the Official Gazette, 1096 OG 30 (15 November 1989). The Art Unit 2814 Fax Center number is (703) 308-7722 or -7724. The Art Unit 2814 Fax Center is to be used only for papers related to Art Unit 2814 applications.

Any inquiry concerning this communication or earlier communication from the examiner should be directed to **Kurt Eaton** at **(703) 305-0383** and between the hours of 8:00 AM to 4:00 PM (Eastern Standard Time) Monday through Friday or by E-mail via **Kurt.Eaton@uspto.gov**.

Olik Chaudhuri Supervisory Patent Examiner Technology Center 2800